

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hideaki Takizawa  
Serial No.:  
Conf. No.:  
Filed: January 30, 2004  
For: PATTERN FORMING METHOD,  
METHOD OF MANUFACTURING THIN  
FILM TRANSISTOR SUBSTRATE,  
METHOD OF MANUFACTURING  
LIQUID CRYSTAL DISPLAY AND  
EXPOSURE MASK

Art Unit:

Examiner:

I hereby certify that this paper is being deposited with the United States Postal Service as EXPRESS MAIL in an envelope addressed to: MS Patent Application, Commissioner for Patents, Alexandria, VA 22313-1450, on this date.

Jan. 30, 2004  
Date

  
Express Mail No. EV032731372US

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This IDS is submitted under 37 C.F.R. §1.97(b) within either of the following time periods, whichever occurs last:

- (a) within three months of either the filing date of the national application or the date of entry into the national stage; or
- (b) before the mailing date of first office action on the merits (i.e., not including actions such as restriction requirements).

Applicant(s) submit herewith Form PTO-1449 (Information Disclosure Citation) together with copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 C.F.R. §1.56. Applicant(s) respectfully submit that the citation of any reference on Form PTO-1449 does not constitute an admission that the reference qualifies as prior art.


It is requested that the information disclosed on the enclosed Form PTO-1449 be made of record in this application.

The Commissioner is hereby authorized to charge any additional fees which may be required to this application under 37 C.F.R. §§1.16-1.17, or to credit any overpayment, to Deposit Account No. 07-2069. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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Form PTO-1449 U.S. Department of Commerce  
(Rev. 8-88) Patent and Trademark Office

Attorney Docket No.: 1324.69359

Serial No.:

INFORMATION DISCLOSURE CITATION  
(Use several sheets if necessary)

Applicant: Hideaki Takizawa

Filing Date: Jan. 30, 2004

Group:

#### U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

#### FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	62-105146	May 15, 1987	Japan			Abs.	
	2-143513	Jun. 1, 1990	Japan			Abs.	
	6-324474	Nov. 25, 1994	Japan			Abs.	
	9-236930	Sep. 9, 1997	Japan			Abs.	
	9-298155	Nov. 18, 1997	Japan			Abs.	
	11-174402	Jul. 2, 1999	Japan			Abs.	
	WO 95/16276	Jun. 15, 1995	Japan			Abs.	

#### OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


Examiner

Date Considered

\*Examiner:

Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.